TITLE: METHOD OF MANUFACTURING A
SEMICONDUCTOR DEVICE AND A
SEMICONDUCTOR DEVICE OBTAINED BY MEANS OF SAID METHOD

INVENTOR: Nicolaas J.A. VAN VEEN et al. DOCKET NO.: NL 010069 CONTACT: Michael E. Marion (914) 333-9641

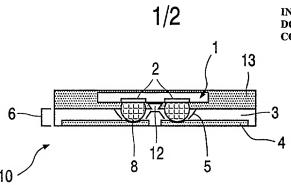


FIG. 1

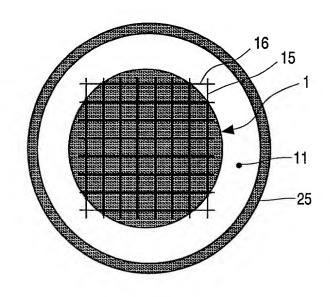


FIG. 3A

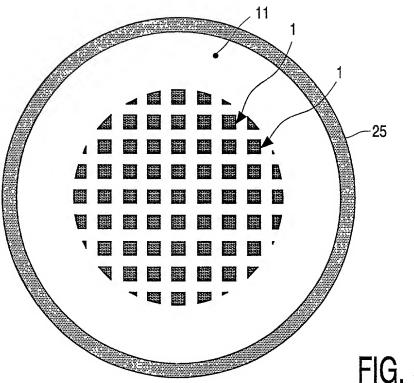


FIG. 3B

TITLE: METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE AND A SEMICONDUCTOR DEVICE OBTAINED BY 2/2 MEANS OF SAID METHOD INVENTOR: Nicolaas J.A. VAN VEEN et al. DOCKET NO.: NL 010069 CONTACT: Michael E. Marion (914) 333-9641 9 10 FIG. 2A FIG. 2B 10 FIG. 2C 10 12 FIG. 2D 10 12 2 11 FIG. 2E 10

